

PCN# : P6C1AAB Issue Date : Apr. 28, 2017

DESIGN/PROCESS CHANGE NOTIFICATION

This is to inform you that a change is being made to the products listed below.

Unless otherwise indicated in the details of this notification, the identified change will have no impact on product quality, reliability, electrical, visual or mechanical performance and affected products will remain fully compliant to all published specifications. Products incorporating this change may be shipped interchangeably with existing unchanged products.

This change is planned to take effect in 90 calendar days from the date of this notification. Please work with your local ON Sales Representative to manage your inventory of unchanged product if your evaluation of this change will require more than 90 calendar days.

Please contact your local Customer Quality Engineer within 30 days of receipt of this notification if you require any additional data or samples.

Implementation of change:

Expected First Shipment Date for Changed Product :Jul. 27, 2017

Expected First Date Code of Changed Product :1731

Description of Change (From):

6-inch wafer fabrication at ON Semiconductor in Bucheon, South Korea

Description of Change (To):

6/8-inch wafer fabrication at ON Semiconductor in Bucheon, South Korea

Reason for Change:

ON Semiconductor is increasing wafer fabrication capacity by qualifying 8-inch wafer fabrication line at ON Semiconductor Bucheon Korea. Quality and reliability remain at the highest standards already demonstrated within ON's existing products.

The reliability qualification results used to qualify the 8-inch wafer fabrication line are summarized below. Design, die size and layout of the affected products will remain unchanged. There are no changes in the datasheet or electrical performance.

Affected Product(s):

| FCD1300N80Z | FCD2250N80Z | FCD3400N80Z |
|----------------|--------------|--------------|
| FCD850N80Z | FCP850N80Z | FCPF1300N80Z |
| FCPF1300N80ZYD | FCPF2250N80Z | FCPF4300N80Z |
| FCPF650N80Z | FCPF850N80Z | FCU2250N80Z |
| FCU3400N80Z | FCU4300N80Z | FCU850N80Z |

| Qualification Plan | Device | Package | Process | No. of Lots |
|--------------------|-------------|---------|------------|-------------|
| QP131201 | FCPF400N80Z | TO-220F | Super-FET2 | 3 |

| Test Description: | Condition: | Standard : | Duration: | Results: |
|--------------------------------|------------------------|-------------|------------|----------|
| High Temperature Gate Bias | 150°C, Vgs = 20V | JESD22-A108 | 1000 hrs | 0/231 |
| High Temperature Reverse Bias | 150°C, Vr = 800V | JESD22-A108 | 1000 hrs | 0/231 |
| High Temperature Storage Life | 150°C | JESD22-A103 | 1000 hrs | 0/231 |
| Highly Accelerated Stress Test | 130°C, 85%RH, Vr = 42V | JESD22-A110 | 96 hrs | 0/231 |
| Temperature Cycle | -65°C, 150°C | JESD22-A104 | 500 cycles | 0/231 |

| Qualification Plan | Device | Package | Process | No. of Lots |
|--------------------|------------|---------|------------|-------------|
| QP131202 | FCD850N80Z | DPAK | Super-FET2 | 1 |

| Test Description: | Condition: | Standard : | Duration: | Results: |
|--------------------------------|------------------------|-------------|-------------|----------|
| MSL1 Precondition | 260°C, 3 cycles | JESD22-A113 | n/a | 0/308 |
| High Temperature Gate Bias | 150°C, Vgs = 20V | JESD22-A108 | 1000 hrs | 0/77 |
| High Temperature Reverse Bias | 150°C, Vr = 800V | JESD22-A108 | 1000 hrs | 0/77 |
| High Temperature Storage Life | 150°C | JESD22-A103 | 1000 hrs | 0/77 |
| Highly Accelerated Stress Test | 130°C, 85%RH, Vr = 42V | JESD22-A110 | 96 hrs | 0/77 |
| Temperature Cycle | -65°C, 150°C | JESD22-A104 | 1000 cycles | 0/77 |